WHAT IS CLAIMED IS:

- A light scanning system formed on a common substrate comprising:
- a light scanner, integrated on said substrate, for scanning light across a target; and
- a sensor, integrated on said substrate, for detecting light reflected from said target and creating a signal representative of said detected light.
- 2. A light scanning system according to claim 1, wherein said light scanner includes:
- a light source, integrated on said substrate, for producing a light beam; and
- a deflector, integrated on said substrate afor the deflecting said light beam across said target single desired our said in pattern.
- 3. A light scanning system according to claim 2, wherein said light scanner further includes:
- a first lens for focusing the light beam produced by the light source.
- 4. A light scanning system according to claim 3, wherein said light source is aligned with an optical axis of said first lens.
- 5. A light scanning system according to claim 3, wherein said light source is offset from an optical axis of said first lens.
- 6. A light scanning system according to claim 3, wherein said light scanner further includes:

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a second lens for focusing the light beam deflected by said deflector.

- 7. A light scanning system according to claim 6, wherein said first lens is a positive lens and said second lens is a negative lens.
- 8. A light scanning system according to claim 2, wherein said light scanner further includes:
- a lens for focusing the light beam deflected by said deflector.
- 9. A light scanning system according to claim 2, wherein said deflector comprises a micro-machined scan module.
- 10. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

a scanning mirror mounted in a center of said sensor;

hinges connected to said detector to allow said detector
and said scanning mirror to rotate about a rotation axis; and

- a frame secured to said substrate for supporting said and hinges.
- 11. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

an electrode;

- a support mounted on said electrode; and
- a mirror element mounted at one end on said support, and wherein a voltage applied between said electrode and mirror element bends said mirror element.

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12. A light scanning system according to claim 9, wherein said micro-machined scan module comprises:

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a scanning mirror;

hinges connected to said scanning mirror to allow said scanning mirror to rotate about a rotation axis; and

- a frame secured to said substrate for supporting said hinges.
- 13. A light scanning system according to claim 12, wherein said rotation axis is perpendicular to a path of said focused light beam from said light source.
- 14. A light scanning system according to claim 12, wherein said light source comprises a laser diode focusing module mounted on a first portion of said substrate.
- 15. A light scanning system according to claim 14, wherein said frame is secured on a second portion of said substrate, which is parallel to said first portion of said substrate.
- 16. A light scanning system according to claim 14, wherein said frame is secured on a second portion of said substrate, which is sloped with respect to said first portion of said substrate cracic
- 17. A light scanning system according to claim 14, wherein said frame is mounted on said first portion of said substrate.
- 18. A light scanning system according to claim 12, wherein said hinges include a shape memory alloy.
- 19. A light scanning system according to claim 18, wherein said shape memory alloy is titanium nickel.
- 20. A light scanning system according to claim 12, wherein said light scanner further includes:

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electrodes for generating an electrostatic force by applying a voltage between each of said electrodes and said scanning mirror.

- 21. A light scanning system according to claim 20, wherein said electrodes include substrate electrodes disposed under said scanning mirror.
- 22. A light scanning system according to claim 21, wherein said electrodes further include upper electrodes disposed above said scanning mirror.
- 23. A light scanning system according to claim 20, wherein said electrodes include upper electrodes disposed above said scanning mirror.
- 24. A light scanning system according to claim Ay wherein accordin

a light source for producing a light beam; and said source hinges connected to said light source to allow said light source to rotate about a rotation axis.

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25. A micro-machined mirror for scanning a light beam from an incident path to a desired pattern in a barcode scanner mounted on a common substrate, comprising:

a reflector for reflecting a light beam;

hinges connected to said reflector to allow said reflector to rotate about a rotation axis; and

a frame secured to said substrate for supporting said hinges.

- 26. A micro-machined mirror according to claim 25, wherein said hinges includes a shape memory alloy.
- 27. A micro-machined mirror according to claim 26, wherein said shape memory alloy is nickel titanium.
- 28. A micro-machined mirror according to claim 25, further comprising an electrode for generating an electrostatic force to rotate the reflector around said rotation axis.

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- 29. A method of manufacturing a scanner on a common substrate comprising the steps of:
 - (a) forming a light diode for producing a light beam;
 - (b) mounting said light diode to said common substrate;
- (c) forming a light scanner for scanning the light beam in a desired pattern; and
- (c) mounting said light scanner to said common substrate.
- 30. A method of manufacturing a scanner on a common substrate comprising the steps of:
- (a) forming a light diode for producing a light beam on said common substrate; and
- (b) forming a light scanner for scanning the light beam in a desired pattern on said common substrate.

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